

A Crash Course on Transmission Electron Microscopy and Electron Energy Loss Spectroscopy

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https://sites.google.com/site/xinhuolin/Home



http://mods-n-hacks.wonderhowto.com/how-to/start-fire-with-your-water-bottle-0137955/ Start a fire with a water bottle

MSAE E8235x: selected topics in materials science, Columbia University, Nov 18, 2015

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Motivation for building an electron microscope



- 1. It is easy to accelerate electrons (charged particles)
- 2. It is easy to focus electrons (use magnetic or electric field)
- 3. Higher resolution than optical/X-ray microscopes—atomic resolution is routine now
- 4. Chemical and bonding imaging and spectroscopy
- 5. Radiation damage limits imaging resolution but it is not as bad as Xray [ref: Henderson, Quarterly Reviews of Biophysics 28, 171 (1995)] Huolin Xin 2015

Biological and Electronic Component Dimensions



Slide credit: DA Muller



Comparison of Optical and Electron Microscopes





Image formed by scanning a small spot



The cross section of a real TEM





Electromagnetic Lens



Electromagnetic Lenses Electromagnetic lenses are comprised of windings of wire through which electric current is applied. This creates a strong magnetic field through which negatively-charged electrons must pass. Source of electrons Axis Focal Electron point trajectory Copper winding Iron shroud Magnetic lens field Due to the magnetic field, the electrons follow a helical trajectory which converges at a fine focal point after it emerges from the lens. (DC-powered magnets behave similar to converging glass lenses) Field Strength determines the focal length which varies with: (focal length) $f = K (V / i^2)$ K = constant based on the number of turns of lens coil wire and the geometry of the lens. V = accelerating voltage i = milliamps of current put through the coil

Potentiometer controls which vary the current to the various lenses are the means by which focus and magnification of the electron beam are achieved.

http://www.microscopy.ethz.ch/lens.htm http://www.udel.edu/biology/Wags/b617/ tem/tem.htm Huolin Xin 2015



Focal Length can be Changed in TEM





A Transmission Electron Microscope



http://www.ammrf.org.au/myscope/images/tem/tem_beampath_stage_a.png Huolin Xin 2015



From micrometers to atomic scales



Science 27 March 2009: Vol. 323 no. 5922 pp. 1705-1708



Propagation of Wave Front

Fresnel diffraction integral

$$E(x,y,z) = \frac{z}{i\lambda} \iint_{-\infty}^{+\infty} E(x',y',0) \frac{e^{ikr}}{r^2} dx' dy'$$

Fresnel diffraction: near field

$$\begin{split} E(x,y,z) &= \frac{e^{ikz}}{i\lambda z} \iint_{-\infty}^{+\infty} E(x',y',0) e^{\frac{ik}{2z}[(x-x')^2 + (y-y')^2]} dx' dy' \\ E(x,y,z) &= \frac{e^{ikz}}{i\lambda z} e^{i\frac{\pi}{\lambda z}(x^2 + y^2)} \mathcal{F}\left\{ E(x',y',0) e^{i\frac{\pi}{\lambda z}(x'^2 + y'^2)} \right\} \Big|_{p=\frac{x}{\lambda z}; q=\frac{y}{\lambda z}} \end{split}$$

Fraunhofer diffraction: far field

$$z \gg \frac{x^{\prime 2} + y^{\prime 2}}{\lambda}$$

$$E(x, y, z) = \frac{e^{ikz}}{i\lambda z} e^{i\frac{\pi}{\lambda z}(x^2 + y^2)} \mathcal{F}\left\{E(x^{\prime}, y^{\prime}, 0)e^{i\frac{\pi}{\lambda z}(x^{\prime 2} + y^{\prime 2})}\right\}\Big|_{p=\frac{x}{\lambda z}; q=\frac{y}{\lambda z}}$$

Huygens-Fresnel principle



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What does a lens do?



• It focuses the Fraunhofer diffraction pattern to the back focal plane;

Fraunhofer diffraction: far field

$$E(x,y,z) = \frac{e^{ikz}}{i\lambda z} e^{i\frac{\pi}{\lambda z}(x^2 + y^2)} \mathcal{F}\left\{E(x',y',0)e^{i\frac{\pi}{\lambda z}(x'^2 + y'^2)}\right\}\Big|_{p=\frac{x}{\lambda z}; q=\frac{y}{\lambda z}}$$



A Converging Lens is Fourier Transform



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How does a STEM create an electron probe



• The electron probe is a simple Fourier transform a round aperture



Imaging with a perfect Lens



• The image of a point transferred through a lens with a circular aperture of semiangle α_{max} is an Airy disk of diameter $d_0 = \frac{0.61\lambda}{\alpha_{max}}$



Spherical Aberration

"For lenses made with spherical surfaces, rays which are parallel to the optic axis but at different distances from the optic axis fail to converge to the same point."



http://hyperphysics.phyastr.gsu.edu/hbase/geoopt/aber.htim2015



- For electron optics: Scherzer showed that the expression for C_s is a sum of squares (always positive) if:
 - The optical system is rotationally symmetric,
 - The system produces a real image of the object,
 - The fields of the system do not vary with time,
 - There is no charge on the axis.



Resolution limits imposed by 3rd Order Spherical Aberrations



• So, FEI analytical pole piece: $C_3 = 1.2 mm$, $\alpha = 9.2 mrad$

 $d_{min} = 0.48 \, nm_{\rm Huolin \ Xin \ 2015}$



Balancing Spherical Aberration against the Diffraction Limit

First Order Approximation

$$d^2 \approx d_{diff}^2 + d_{sph}^2 = \left(\frac{0.61\lambda}{\alpha_{max}}\right)^2 + \left(\frac{1}{2}C_3\alpha_{max}^3\right)^2$$





Balancing Spherical Aberration against the Diffraction Limit

A more accurate wave-optical treatment, allowing less than $\lambda/4$ of phase shift across the lens gives

Optimal aperture size: $\alpha_{opt} = \left(\frac{4\lambda}{C_3}\right)^{1/4}$

Minimum Spot size:
$$d_{min}=0.43{ imes}C_3^{1/4}\lambda^{3/4}$$



At 200 keV

- C3 I.2 mm, I.6 Angstrom
- C3 I.0 mm, I.52 Angstrom
- C3 0.5 mm, I.28 Angstrom
- C3 0.1 mm, 0.86 Angstrom

Why you don't want to use too big an aperture



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Contrast Reduces if Aperture is Too Large





Hardware Advances in Microscopy





Muller, Nature Materials, (2009), Adapted from Rose (2009) in 2015



Depth Sectioning and Confocal Imaging in an Aberration-Corrected S/TEM



3D Point Spread Function of ADF-STEM



• The short depth of focus could potentially enable 3D reconstruction of nanomaterials through acquisition of a through-focal series in a similar manner to confocal microscopy.

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Depth Sectioning and Confocal Imaging in an Aberration-Corrected S/TEM



3D Point Spread Function of ADF-STEM

• The short depth of focus could potentially enable 3D reconstruction of nanomaterials through acquisition of a through-focal series in a similar manner to confocal microscopy.



Depth Sectioning of Impurity Atoms



reveal the depth profile of a impurity atoms in amorphous layers (no electron channeling). Huolin Xin 2015



Through-focal series of Ru-TaN ~6nm

Animation: Defocus interval: 2nm # of Slices: 16

BROOKHAVEN Reconstruction of Extended Features by ADF-STEM Depth Sectioning

ADF-STEMThrough-focal Series Pt-Co Clusters on Carbon Support



100 KeV, 33 mrad, df = -500-500nm, 51 frames



l 000nm

• 5 nm particles are elongated to a few hundred nanomaters long. Hullin Xin 2015



Depth Sectioning Artifacts: Inside or Outside?



STEM depth sectioning reconstruction can be confusing and not direct interpretable.

HL Xin and DA Muller, Journal of Electron Microscopy, 98, 157 (2005)



The T = 0 problem

Focused beam induced coarsening at (>300 pA)



High-dose imaging in gas 4500/Ang.²/sec



Is it a pitfall of electrons?



Fast Electron vs. X-ray



It's not the **cross-section**, but

How many damaging events per useful imaging event.

Least Damage Elastic Imaging – Electrons win Inelastic imaging – Soft X-rays win

Henderson, Quarterly Reviews of Biophysics 28, 171 (1995)

Elastic information per damaging event (i.e. ionizing event)



• Can we do SLAC-type of protein crystallography with electrons?

Data from Breedlove and Trammell, Science 170 (1970) 1310

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For electrons σ_i/b_e^{I} olin (K) n 2015



Can we do Free Electron Laser-type of protein crystallography with short electron pulses?



- We have really good lateral and longitudinal **coherence** with electrons
- What are the limitations?

Proceedings of FEL 2006, BESSY, Berlin, Germany



Electron Mean Free Path





Mean free path for 100 keV electrons

Henderson, Quarterly Reviews of Biophysics 28, 171 (1995)



Difficult Using Electron Pluses due to the Space Charge Effect



 The temporal width of the electron pulses decreases quickly with the number of electrons



XJ Wang, J. Hill, and Y. Zhu et al, arXiv:1304.5176 Diffraction Patter of 1T-TaS2 40-120 fs single pulse of 3x10^4 2.8 MeV electrons

J. Phys.: Condens. Matter **21** (2009) 314003


Diffract but not Destroy



Critical dose is low, but elastic scattering cross section is large. Ratio between useful event vs. damaging event is high.



Diffract but not Destroy



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Coherent diffraction from a single nanoparticle



JM Zuo, Chapter on ELECTRON NANOCRYSTALLE



Passing though a zone axis







Electron Diffraction is Highly Dynamical

Silicon <110>



Thickness fringes



Thicknesses determined by comparing position independent CBED (scanning probe CBED) with Block-wave CBED simulations.



Electron diffraction is sensitive to the change in lower-order structure factors.



http://cbed.matse.illinois.edu/

• Quantitative electron diffraction is good for charge density reconstruction in a wide range of crystalline/poly-crystalline materials (sensitivity + spatial resolution)



Atomic-Resolution Spectroscopic Imaging and In Situ Environmental Study of Bimetallic Nanocatalysts





Coherent Imaging (HRTEM) is Confusing





Scanning Transmission Electron Microscopy





Application of "Z-Contrast" – Z^{γ}





Hovden et al, Ultramicroscopy 123, December 2012, Pages 59–65

Krivanek et al, Nature **464**, 571-574 (25 March 2010)

ADF detector (outer angle=240 mrad) varies with inner angle for a 60 keV STEM (convergence angle 30 mrad, C_{S3} =-0.018 mm, C_{S5} =20.0 mm, df=-30.4 nm).

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Not always "Z-Contrast" Caveat: Low-angle ADF and Strain Fields





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L. Fitting et al, Ultramicroscopy, 106, 105 (2006)5



Electron Energy Loss Spectrum of SiO₂





Core-Level Near-Edge Electron Energy Loss Spectroscopy (EELS)



EELS measures the empty local density of states (the conduction band) partitioned by •site - as the probe is localized, •element - the core level binding energy is unique •angular momentum - (s,p,d states separately) HOWEVER •DOS modified by presence of core hole



X-ray absorption spectroscopy (XAS) vs EELS

XAS

$$\sigma = \sum_{i,f} 4\pi^2 \hbar \alpha \omega |\langle f| \boldsymbol{\varepsilon} \cdot \mathbf{R} |i\rangle|^2 \delta(\boldsymbol{E} + \boldsymbol{E}_i - \boldsymbol{E}_f),$$

Absorb a photon

Polarization vector $\boldsymbol{\varepsilon}$ is determined by your incident setup





$$\begin{aligned} \frac{\partial^2 \sigma}{\partial E \partial \Omega} &= \sum_{i,f} \left. \frac{4\gamma^2}{a_0^2 q^4} \frac{k_f}{k_i} \right| \left\langle f \left| \sum_{j=1}^n e^{i\mathbf{q}\cdot\mathbf{R}_j} \right| i \right\rangle \right|^2 \delta(E_i - E_f + E) \\ &= \sum_{i,f} \left. \frac{4\gamma^2}{a_0^2 q^4} \frac{k_f}{k_i} |\langle f | \mathbf{q} \cdot \mathbf{R} | i \rangle|^2 \delta(E_i - E_f + E), \end{aligned} \tag{1}$$

Absorb a virtual photon

The equivalent polarization vector \mathbf{e}_q = \mathbf{q}/q is determined by your collection setup





Dipole Approximation is good for Core Level EELS

(except when the probe < core orbital size)



P. Rez, Ultramicroscopy 28 1989 16 Pupolin Xin 2015

Dipole vs. Multipole in Aberration-Corrected STEM-EELS



Dipole dominates the broad tails of the STEM-EELS profile: 80% of total intensity Dipole gives upper bound to spatial resolution (monopole is a bit narrower)



Monochromated EELS



- General rule: valence ↑
 - edge onset ↑
- Edge onset shift however does not always track the magnitude of the core level shift (e.g. latter 3-d TM).
- Slightly more complicated for insulators due to the presence of excitonic features





• Core-hole life time in c-Si is relatively short. The spectrum resembles the ground state calculation.





• Strong core-hole effects on the silicon-L Edge in SiO₂

(it does not reflect the ground state)







Tradeoff: Probe Size for Beam Current

 $I_{coll} = \beta x$ (Probe Area) x (Probe Solid Angle) x (Collection Efficiency)



D.A. Muller, Nature Materials, 8, 263 (2009)



EELS Collection Efficiency

Improved Dose efficiency, improved interpretability





Atomic Resolution Spectroscopic Imaging of STO/LVO Multilayer



 La in green, Ti in red, and V in blue.

Science, 2008

Kourkoutis, **Xin**, et all Phil. Mag., **90**, 4731 (2010) Huolin Xin 2015

64x64



Co/Silica Porous Catalyst for Carbon Monoxide (CO) Hydrogenation



HL Xin et al, ACS Nano, 6, 4241, (2012)

Need to reduce Co oxide to metallic cobalt. What's the optimal reduction temperature?



Connecting In situ Imaging with Electronic Structures of the Materials



 Building a correlation between structural coarsening and valence state changes allow us to understand the underlying mechanisms in the catalyst optimization used in the industry HL Xin et al, ACS Nano, 6, 4241, (2012)



Reaction Pathway







 $C_{0}O + H_{2} = C_{0} + H_{2}O$



Principle Component Analysis of Partially Reduced CoO Porous Networks





Critical Thinking



and many more.....



Fig. 5.1. A single projection image is plainly insufficient to infer the structure of an object. Drawing by John O'Brien; © 1991 The New Yorker Magazine.



Tomography Experiment



Acquisition

Slab Geometry:

- One image every I-2° from $\pm 70^{\circ}$
- 70 140 images



Reconstruction

Requirement:

 Image intensities vary monotonically with thickness

(STEM is superior to TEM for tomography because TEM suffers from phase contrast and diffraction contrast which breaks the monotony of the signal)

BROOKHAVEN NATIONAL LABORATORY 3-D Reconstruction of Pt-Co particles on Support



20 nm

Huolin L. Xin et al, Nano Lett., 12, 490 (2015)



Ex-Situ: Coarsening During Voltage Cycling



Y.Yu*, H.L.Xin* (*cofirst author), Nano Lett., 12 (9),4417-4423 (2012) Huolin Xin 2015



Observing Coalescence in 3-D



Tracking individual particles and how they move on the support to coalesce

Y.Yu*, **H. L. Xin*** (*equal), <u>Nano Lett.</u>, 12 (9),4417-4423 (2012)



Chemical Dealloying of Pt-Co Nanoparticles



• Leaching of Co left holes and divots in the remaining Pt



A Schematics for ETEM



Crozier et al, Ultramicroscopy, **III**, 177 (2011)


Oxidation of 12nm PtCo Particles

400°C + 0.14 Torr O₂





• Co diffuse out causing the Pt core to either shrink or forming holes

Xin et al, Narducetters, 2014

2 nm



Atomic Scale Real Time Imaging of Oxidation of Individual Co-Pt Nanocatalysts



Xin et al, Nanoucline Xin 2014







• 250°C in 0.1 mbar O₂

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(Animated GIF. Play in presenting mode.)

Xin et al, Nano Letters, 2014



GPA Strain Mapping



Xin et al, Nanoucline Xin 2014



Low Concentration of Pt in Co



• Much larger porousness in the dilute Pt system

Samples provided by Chen CherryPointarig 2015



Low Concentration of Pt in Co

Oxidation (~ $30 \text{ mTorr } O_2 + 300^{\circ}\text{C}$)





Pt:Co = I:I



Kirkendal Voids Forming Dynamics



Ramping from 150 to 250°C in oxidation environment (1 atm)



25 nm

• Oxidation dynamics of cobalt nanoparticles

Xin et al, Microscopy and Microalial Sig, 2015



Gas Pressure Can Modify Spatial Dependent Reaction Kinetics



 Disclaimer: I have no intention to discredit differentially pumped ETEM.

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